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Title of the invention: Microcorner cube, microcorner-cubic array, their manufacture and display device for
5 which microcorner-cubic array is used

(Claims)

3. A method of making a microcorner cube, the method comprising:

10 exposing a layer of a photoresist formed into a fixed thickness on a surface of a transparent board by making use of a microscopic mask in which transmittance or shading rate reduces gradually by facing toward sides from the center of a regular triangle, and developing the photoresist to form a
15 triangular-pyramidlike microscopic protrusion,

transferring the form of the photoresist to the transparent board by engraving through anisotropic etching, to form, as a part of the transparent board, the triangular-pyramidlike microscopic protrusion having three faces of
20 equilateral right-angled triangles combined with each other in a state meeting at right angles.

4. A method of making a microcorner-cubic array, the method comprising:

25 exposing a layer of a photoresist formed into a fixed

PATENT ABSTRACTS OF JAPAN

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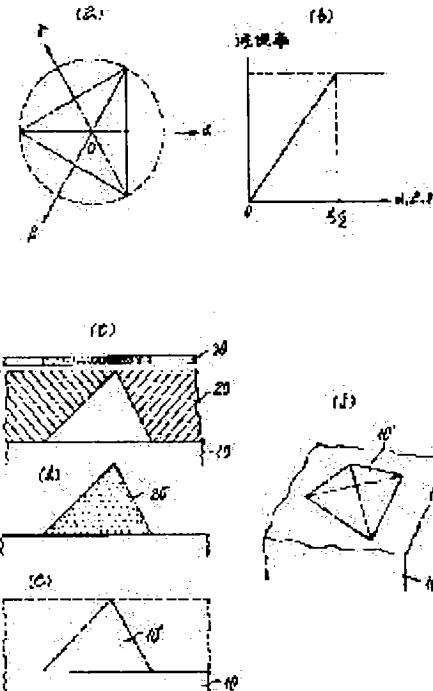
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(54) MICROCORNER CUBE MICROCORNER-CUBIC ARRAY, THEIR MANUFACTURE AND DISPLAY DEVICE FOR WHICH MICROCORNER-CUBIC ARRAY IS USED

(57)Abstract:

PURPOSE: To provide a manufacture of a microcorner cube. CONSTITUTION: Exposure is performed to a layer of a photoresist 20 formed into a fixed thickness on the surface of a transparent board 10 by making use of a microscopic mask 30 in which transmittance or shading rate is reducing gradually by facing toward sides each from the center of a regular triangle and a triangular-pyramidlike microscopic protrusion 20' is formed by the photoresist through development. Since the form 20' of the photoresist is transferred to the transparent board 10 by engraving by performing anisotropic etching after that, the triangular-pyramidlike microscopic protrusion 10' which is comprised by combining three faces of equilateral right-angled triangles with each other in a state meeting at right angles is formed as a part of the transparent board 10.



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